

2128  
EFW



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q62740

Masahiro MAEDA

Appln. No.: 09/765,639

Group Art Unit: 2128

Confirmation No.: 6818

Examiner: Morella I. Rosales Hanner

Filed: January 22, 2001

For: METHOD OF EVALUATING REFLECTION PERFORMANCE OF REFLECTING MIRROR, EVALUATION SYSTEM FOR EVALUATING REFLECTION PERFORMANCE OF REFLECTING MIRROR, AND COMPUTER-READABLE STORAGE MEDIUM STORING PROGRAM FOR

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 3, 2004, please amend the above-identified application as follows on the accompanying pages.

**TABLE OF CONTENTS**

AMENDMENTS TO THE CLAIMS .....	2
AMENDMENTS TO THE DRAWINGS.....	9
REMARKS .....	10